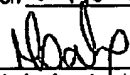


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CENTRAL FAX CENTER****NOV 29 2006****IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
(Attorney Docket No. 100176)**

First Inventor: Roland K. Sevilla
Serial No.: 10/601,601
Filing Date: 06/23/2003
Title: POLISHING PAD FOR
ELECTROCHEMICAL-
MECHANICAL POLISHING
Examiner: Maurina T. Rachuba
Art Unit: 3723

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I, Mariejose Monsalvo, hereby certify that this paper and enclosure(s), if any, are hereby being transmitted by facsimile to the US Patent and Trademark Office's central fax No. (571) 273-8300 on 29 Nov 06.


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RESPONSE TO Office Action

This is a reply to the Office Communication mailed November 1, 2006 for the above captioned U.S. patent application.

Amendments to the Claims are reflected in the listing of claims that begins on page 2 of this paper.

Remarks begin on page 4 of this paper.

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